

Attorney Docket No. 071469-0304673  
Client Reference: RAJ-003A

*PATENT*

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of: Noriaki FUKIAGE

Application No.:

Confirmation

No:

Filed: August 21, 2003

Group No.:

Examiner

For: Method and Apparatus for Depositing Materials with Tunable Optical Properties and Etching Characteristics

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**APPLICATION DATA SHEET**  
**37 C.F.R. § 1.76**

**BIBLIOGRAPHIC DATA**

**1. Applicant information**

First applicant: Noriaki FUKIAGE  
Citizenship: JAPAN  
Residence: 50 E. Hartsdale Avenue, Apt. 3C, Hartsdale, NY 10530

**2. Correspondence information**

Correspondence for this application should be addressed as follows:

Customer No.: 00909

**3. Application information**

Title of Invention: Method and Apparatus for Depositing Materials with Tunable Optical Properties and Etching Characteristics

Docket number assigned to this application: 071469-0304673

Suggested Classification: Class:

Subclass:

Technology Center to which subject matter is assigned:

Total number of drawing sheets: 4

Type of application:

Utility

Application is to be published. Suggested drawing figure for publication:

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Secrecy order under § 5.2:

This application does not disclose subject matter of an application which is under a secrecy order pursuant to § 5.2.

**4. Representative information**

The following have a power of attorney or authorization of agent in this application:

Customer No.: 00909

**5. Assignee information**

The assignee(s) of this application is/are:

Tokyo Electron Limited  
3-6, Akasaka 5-chome, Minato-ku  
Tokyo, 107  
JAPAN

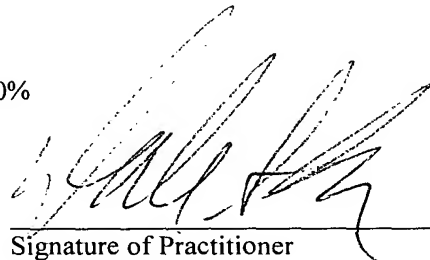
Extent of interest of assignee in application: 100%

Date: August 21, 2003

Reg. No.: 28872

Tel. No.: (703) 905-2126

Customer No.: 00909

  
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Signature of Practitioner  
Dale S. Lazar  
Pillsbury Winthrop LLP  
P.O. Box 10500  
McLean, VA 22102